Docket No. 292134US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Masaru SASAKI, et al.

SERIAL NO: 10/581,601 ART UNIT: 2812

FILING DATE: June 5, 2006 EXAMINER: Seahvosh J. Nikmanesh

FOR: METHOD OF CLEANING SEMICONDUCTOR SUBSTRATE CONDUCTIVE LAYER SURFACE

FEE TRANSMITTAL

No additional fee is required

☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.

The Fee has been calculated as shown below:

FOR NUMBER FILED		NUMBER EXTRA	RATE		CALCULATIONS		
TOTAL CLAIMS	18 -	25	=	0	x	\$50 =	\$0.00
INDEPENDENT CLAIMS	2 -	3	=	0	х	\$210 =	\$0.00
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- ☐ A check in the amount of \$0.00 to cover the filing fee is enclosed.
- Online credit card payment is being made to cover the filing fee in the amount of \$0.00
- The Director is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030.

Submitted by:

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